. . . . INFORMATION DISCLOSURE STATEMENT PC' PCI/PTO 30 WAR 2005 Sheet 1 of 1 SERIAL NOT 0 / 529760 FORM PTO 1449 (modified) ATTY DOCKET NO. 2005-0526A U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE APPLICANT Daisuke FUJITA LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) FILING DATE GROUP 2818 Date Submitted to PTO: March 30, 2005 March 30, 2005 **U.S. PATENT DOCUMENTS** DOCUMENT CLASS SUBCLASS FILING DATE IF *EXAMINER DATE NAME NUMBER APPROPRIATE INMAL AA 6.608.306 8/2003 Aono et al. PD AB AC AD ΑE AF AG AH ΑI **FOREIGN PATENT DOCUMENTS** TRANSLATION CLASS SUBCLASS DOCUMENT DATE COUNTRY YES NUMBER AJ 00/70325 11/2000 . WO ABSTEACT PD ΑK 07-065705 3/1995 Japan PP ABSTRACT AL **AM** OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.) AO C.S. Chang et al., "Field Evaporation between a Gold Tip and a Gold Surface in the Scanning Tunneling Microscope Configuration", Physical Review Letters, Vol. 72, No. 4, pages 574-577, January 24, 1994. PD AΡ D.M. Kolb, "Nanoscale decoration of electrode surface with an STM", Solid State Ionics, Vol. 131, PP pages 69-78, June 1, 2000. D. Fujita and T. Kumakura, "Reproducible fabrication of metallic silver nanostructures on a Si (111)-(7x7) surface AQ PD by tip-material transfer of a scanning tunneling microscope", Applied Physics Letters, Vol. 82, No. 14, pages 2329-2331, April 7, 2003. PHUC DANG DATE CONSIDERED 2007 **EXAMINER**

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.